



18th International Vacuum Congress (IVC-18)

International Conference on Nanoscience and Technology (ICN+T 2010)

14th International Conference on Solid Surfaces (ICSS-14)

Vacuum and Surface Sciences Conference of Asia and Australia (VASSCAA-5)

August 23-27, 2010, Beijing, China

BEST POSTER AWARD

For the best scientific presentation in the poster session

Awarded to

D. Fujita, T. Kumakura, K. Onishi, K. Sagisaka

For the paper

High temperature in situ AFM/STM observation of decomposition and cleaning process of ultrathin SiO₂ films on Si(111) surfaces in ultrahigh vacuum

Jianguo HOU (General Chair of IVC-18, President of CVS)